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| Search Notes *1056702 8* | Application/Control No. 10567028 | Applicant(s)/Patent Under Reexamination PICKLES ET AL. |
| | Examiner Jennifer Dieterle | Art Unit 1759 |

| SEARCHED | | | |
|---------------|--|----------|----------|
| Class | Subclass | Date | Examiner |
| 204 | 400, 415, 416, 418 | 4/23/09 | JMD |
| Updated above | | 5/25/10 | JMD |
| 204 | 400,409,433,412,406,408,410,411,415,416,421,422,434, 280 | 12/12/10 | JMD |
| 205 | | 12/12/10 | JMD |

| SEARCH NOTES | | |
|---|----------|----------|
| Search Notes | Date | Examiner |
| EAST, Google, Inventor | 4/23/09 | JMD |
| Spoke with Kaj Olsen concerning applicant's amendments and verified art is applicable to make rejection final | 10/12/09 | JMD |
| Consulted with Kaj Olsen, also consulted with Alen Olsen concerning etching processes, both indicated that my prior art Shiomi is applicable. | 5/25/10 | JMD |
| EAST, Google, Inventor, consulted with Kaj Olsen | 12/12/10 | JMD |

| INTERFERENCE SEARCH | | | |
|---------------------|--|----------|----------|
| Class | Subclass | Date | Examiner |
| | interference text search of claim language | 12/12/10 | JMD |
| 205 | 775,782.5,786.5,787.5,793,794.5 | 12/12/10 | JMD |
| 204 | 400,409,433,412,406,408,410,411,415,416,421,422,434, 280 | 12/12/10 | JMD |

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